

**Application Data Sheet**

**Application Information**

Application Number::

Filing Date::

Application Type::

Subject Matter::

Suggested Classification::

Suggested Group Art Unit::

Title::

Attorney Docket Number::

Request for Early Publication::

Request for Non-Publication::

Suggested Drawing Figure::

Total Drawing Sheets::

**10/575270**

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**International Application No.**

**PCT/JP2005/004593**

**PCT filed on March 9, 2005**

**U.S. filing on April 11, 2006**

**US National Phase**

**Utility**

**VISIBLE LIGHT RESPONSIVE COMPLEX  
OXIDE PHOTOCATALYST AND METHOD OF  
USING THE SAME TO DECOMPOSE AND  
ELIMINATE HARMFUL CHEMICAL  
SUBSTANCE**

**TCP-008**

**0**

## **Applicant Information**

Applicant Authority Type::	<b>Inventor</b>
Primary Citizenship Country::	<b>Chinese</b>
Status::	<b>Full capacity</b>
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## Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
<b>This Application</b>	<b>US National Stage</b>	<b>PCT/JP2005/004593</b>	<b>March 9, 2005</b>

## Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
<b>JAPAN</b>	<b>2004-070381</b>	<b>March 12, 2004</b>	<b>Yes</b>

## Assignee Information

Assignee Name:: **NATIONAL INSTITUTE FOR MATERIALS  
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